



*ZFA*

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q80484

Tsukasa YAMANAKA, et al.

Appln. No.: 10/801,723

Group Art Unit: 1752

Confirmation No.: 1889

Examiner: Amanda C. Walke

Filed: March 17, 2004

For: POSITIVE RESIST COMPOSITION AND METHOD OF PATTERN FORMATION  
USING THE SAME

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 15, 2006, please consider the following  
remarks.

**TABLE OF CONTENTS**

REMARKS .....	2
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